

IPW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Wei-Jye Lin :
Serial No. : 10/820,743 : Art Unit #2826
Filed : 9 April 2004 : Examiner: A. N. Sefer
Title : CONTACT PROCESS AND STRUCTURE
FOR A SEMICONDUCTOR DEVICE

RESPONSE TO RESTRICTION REQUIREMENT
AND AMENDMENT

Mail Stop NO FEE
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant, by the undersigned attorney hereby responds to the outstanding Official Action dated 21 March 2005 which is a Restriction Requirement. Please amend the above-referenced patent application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.